

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

App. No. : 10/604,133
Applicant : Masuhiro Natsuhara et al.
Filed : June 27, 2003
Title : WAFER HOLDER FOR SEMICONDUCTOR
MANUFACTURING DEVICE AND SEMICONDUCTOR
MANUFACTURING DEVICE IN WHICH IT IS
INSTALLED
Tech. Cntr./Art Unit : (to be assigned)
Examiner : (to be assigned)
Docket No. : 39.017-AG

Honorable Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

This constitutes an Information Disclosure Statement pursuant to 37 C.F.R. §§ 1.97 and 1.98. The attached documents as listed on the accompanying Form PTO/SB/08A are hereby brought to the Examiner's attention in the patent application identified above. A copy of this form accompanies this paper.

Concise Explanation of the Relevance/Copy of Translation
Pursuant to 37 C.F.R. § 1.98(a)(3)(i)&(ii)

Abstracts in English, prepared by Patent Abstracts of Japan, of non-English references JP H04-78138 and JP H13-118664 are readily available to the applicant through the Japanese Patent Office Web site, and are attached to the respective fronts of these Japanese documents.

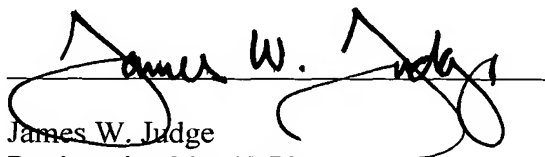
App. No. 10/604,133
IDS Submission

A concise explanation of the relevance of Japanese references JP H04-78138 and JP 2001-118664 is incorporated into the specification in the present application, in paragraphs 0005 and 0006 respectively. Furthermore, machine-translated abstracts thereof, available through the Japanese Patent Office Web site, are attached to the front of each reference.

The Examiner is respectfully requested to consider these references, and to indicate so on the accompanying Form PTO/SB/08A and make the document of record in the present application.

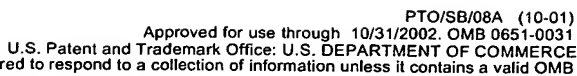
Respectfully submitted,

July 30, 2003



James W. Judge
Registration No. 42,701

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Substitute for form 1449A/PTO

(use as many sheets as necessary)

Sheet	1	of	1
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Complete if Known

Application Number	10/604,133
Filing Date	June 27, 2003
First Named Inventor	Masuhiko Natsuhara
Art Unit	(to be assigned)
Examiner Name	(to be assigned)
Attorney Docket Number	39.017-AG

U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

Examiner
Signature

Date Considered

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

Burden Hour Statement: This form is estimated to take 2.0 hours to complete. Time will vary depending upon the needs of the individual case. Any comments on the amount of time you are required to complete this form should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, Washington, DC 20231. **DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO:** Assistant Commissioner for Patents, Washington, DC 20231.